

Electronic Patent Application Fee Transmittal

Application Number:	10529861			
Filing Date:	31-Mar-2005			
Title of Invention:	PLASMA TREATMENT APPARATUS, METHOD OF PRODUCING REACTION VESSEL FOR PLASMA GENERATION, AND PLASMA TREATMENT METHOD			
First Named Inventor/Applicant Name:	Tetsuji Shibata			
Filer:	Lee Cheng/Maki Huffman			
Attorney Docket Number:	HOK-0270			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
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Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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